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FACSIMILE COVER SHEET

TO: Examiner William T. Leader
U. S. Patent & Trademark Office
Group Art Unit 1742

FROM: Diamond E. Vadnais, Reg. No. 52,310

RE: U.S. Application No. 10/805,323
Atty. Docket No.: 03500.017969

FAX NO.: (571) 273-8300

DATE: January 8, 2007

NO. OF PAGES: 7
(including cover page)

TIME: 4:22 P.M.

SENT BY: L.S.

MESSAGE

Attachments:

Amendment and Response to Restriction Requirement Transmittal
Amendment and Response to Restriction Requirement

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Diamond E. Vadnais, Reg. No. 52,310
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JAN 08 2007

In re Application of:

Docket No. 03500.017969.

MASUMITSU IWATA, et al.

Application No.: 10/805,323

Examiner: William T. Leader

Filed: March 22, 2004

Group Art Unit: 1742

For: ZINC OXIDE FILM TREATMENT METHOD
AND METHOD OF MANUFACTURING
PHOTOVOLTAIC DEVICE UTILIZING THE SAME

Date: January 8, 2007

Mail Stop Amendment
THE COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment and Response to Restriction Requirement in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 7	MINUS	** 20	= 0	x \$25 \$50	\$0
INDEP. CLAIMS	* 1	MINUS	*** 3	= 0	x \$100 \$200	\$0
Fee for Multiple Dependent claims \$180°/\$360						\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$0


* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

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- ☐ Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☐ A check in the amount of \$_____ is enclosed.
- ☐ Charge \$_____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205.
- ☐ A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.
- ☐ A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Diamond E. Vadnais
Attorney for Applicants
Registration No.: 52,310

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PAGE 3/7 * RCVD AT 1/8/2007 7:26:49 PM [Eastern Standard Time] * SVR:USPTO-EFAXF-1/16 * DNIS:2738300 * CSID:714 540 9823 * DURATION (mm-ss):02-08

JAN 08 2007

03500.017969.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MASUMITSU IWATA, et al.) Examiner: William T. Leader
Application No.: 10/805,323) Group Art Unit: 1742
Filed: March 22, 2004)
For: ZINC OXIDE FILM TREATMENT)
METHOD AND METHOD OF)
MANUFACTURING)
PHOTOVOLTAIC DEVICE)
UTILIZING THE SAME) January 8, 2007

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT
AND
RESPONSE TO RESTRICTION REQUIREMENT


Sir:

In response to the Office Action dated December 12, 2006, please amend
the above-identified application as follows:

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I hereby certify that this correspondence is being facsimile
transmitted to the Patent and Trademark Office on:

January 8, 2007
Date


Signature

Damond E. Vadpais, Reg. No. 52,310
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